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Real-time monitoring of structural vibration using spectral-domain optical coherence tomography

Shuncong Zhong^{a,b}, Hao Shen^a, Yaochun Shen^{a,*}

^a Department of Electrical Engineering and Electronics, University of Liverpool, Liverpool L69 3GJ, UK ^b School of Mechanical Engineering and Automation, Fuzhou University, PR China

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ABSTRACT

We report in this paper the development of a spectral-domain optical coherence vibration tomography (OCVT) using a broadband CCD-based spectrometer and a short-coherence white light source. We demonstrate that both the vibration amplitude and frequency can be quantified, in the frequency range 0–250 Hz, with an axial resolution of 1 μ m. Furthermore, the inner structure (layer thickness) of a vibrating sample can also be quantified simultaneously. The developed OCVT is non-contact and noninvasive in nature, thus is ideal for real time and in situ monitoring of low-frequency micro-vibrations that have critical impacts on many high-precision manufacturing and engineering processes.

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1. Introduction

In recent years, there has been an increase in demand from industrial and scientific organizations for vibration monitoring and measurement techniques in applications such as high-precision manufacturing and micro electromechanical system (MEMS) [1–3]. Strain gauge, accelerometer and optical fiber sensor have been employed in the vibration measurements [3–6]. However, these methods require direct contact with the sample and this may limit their applications. Recently, vibration and deformation have been successfully characterised using various non-contact optical interferometers techniques [7-12]. Generally, the displacement is obtained from the phase change of the interferometric patterns, providing extremely high depth resolution (down to 10^{-12} m). However, the detection range is usually limited to half the wavelength of the laser source owing to the 2π phase ambiguity [11]. The detection range can be extended beyond the half wavelength limit by using phase shift/modulation techniques, at the cost of increased instrument complexity and decreased measurement accuracy (related to the inherent phase shift error) [13,14]. On the other hand, laser Doppler vibrometre (LDV) directly measures the velocity of a sample although the displacement information can also be obtained by the integration of velocity along the time axis [6,15].

In all these mentioned methods, only the displacement of a sample is obtained and no information on the inner structure of a

sample could be revealed. In this paper, we will demonstrate that by directly measuring the absolute displacement of a sample using optical coherence tomography (OCT), one can obtain both the inner structure (layer thickness) and the vibration parameters (amplitude and frequency) of the sample simultaneously and in real time.

2. Experiment

Fig. 1 shows the schematic diagram of a spectral-domain optical coherence vibration tomography (OCVT). The light from a 50 W halogen lamp is delivered into a Michelson interferometer using a biconvex lens. Light is then split into reference and sample beams by a beam-splitter (50/50). Both the "object image" and the "reference image" are formed at the entrance slit of a broadband CCD-based spectrometer (USB2000+, Ocean Optics, USA). Interference occurs when both the "object image" and the "reference image" are spatially matched in size and orientation, and their optical path lengths are matched within the coherence length of the light source. The sample used here is a plastic substrate coated with a polymer thin film of ~25 μ m thickness. The sample is attached to a louder speaker that acts as the vibration exciter.

The spectral interferogram of the interferometer can be expressed as

$$I(\lambda,t) = \sqrt{\frac{\varepsilon_0}{\mu_0}} \left| E_r(\lambda) + E_s(\lambda) \right|^2 \tag{1}$$

^{*} Corresponding author. Tel.: +44 151 794 4575; fax: +44 151 794 4540. *E-mail addresses:* y.c.shen@liv.ac.uk (H. Shen), y.c.shen@liv.ac.uk (Y. Shen).

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Nomenclature		$S_{s1}(\lambda)$	the coating/core interface reflection of the sample
		$I_0(\lambda)$	the intensity of the incident light
8 ₀	the vacuum permittivity	Ζ	the depth direction
μ_0	the vacuum permeability	λ_0	centre wavelength of the light
λ	the wavelength of the light	$\Delta\lambda$	a full width at half-maximum (FWHM)
$E_r(\lambda)$	the electrical field from reference	п	refractive index
$E_s(\lambda)$	the electrical field from sample	С	velocity of light in air
$E_i(\lambda)$	the electrical field of incidence light	ν	velocity of light in medium
S_r	the reflection coefficient of the reference	d_1	the thickness of the layer in air
$S_s(\lambda)$	the reflection coefficient of the sample	d_2	the physical thickness of the layer
$I(\lambda,t)$	the spectral interferogram	A(z,t)	amplitude change between successive OCT scan
t	time	$\Delta \phi(z,t)$	the phase change between successive OCT scan
$\Delta l(t)$	the optical path length difference between the	Z _{max}	the amplitude detection range of the micro-vibrations
	reference and sample arm (for vibrating sample)		using vibration OCT
d	thickness of a single coating of a sample	$\delta\lambda$	the spectrometer resolution
$S_{s0}(\lambda)$	the surface reflection of the sample		

where ε_0 and μ_0 are the vacuum permittivity and the vacuum permeability, respectively; the electrical filed from reference (E_r) and sample (E_s) can be written as [16]

$$E_r(\lambda) = S_r E_i(\lambda) \exp\left(\frac{j2\pi tc}{\lambda}\right)$$
(2)

$$E_{s}(\lambda) = S_{s}(\lambda)E_{i}(\lambda)\exp\left(\frac{j2\pi tc}{\lambda} - \frac{j2\pi\Delta l(t)}{\lambda}\right)$$
(3)

where $E_i(\lambda)$ is the electrical field of incidence light; *c* and λ are the velocity and the wavelength of light in air; $\Delta l(t)$ is the optical path length difference between the reference and sample arm, which is a function of t for a vibrating sample. S_r is the reflection coefficient of a reference (mirror) and is wavelength-independent whilst $S_s(\lambda)$ is the reflection coefficient of the sample which is usually wavelength-dependent for a layered sample. For simplicity, we assume (1) the sample has a single coating layer of a thickness of d; (2) the contribution from the multiple reflections within the coating is negligible. The reflection coefficient from a layered sample [17] can then be simplified as

$$S_{s}(\lambda) = S_{s0}(\lambda) + S_{s1}(\lambda) \exp\left(\frac{-j4\pi d}{\lambda}\right)$$
(4)



Fig. 1. Schematic diagram of the spectral-domain OCVT experimental setup. The sample vibration is excited by a loudspeaker. THL, Tungsten Halogen Lamp; EP, Entrance pupil; L, Lens; REF, Reference; BS, Beam-splitter; OF, Optical fiber; S, Samples; LS, Loudspeaker. The inset shows a typical spectral interferogram measured using this setup.

where $S_{s0}(\lambda)$ and $S_{s1}(\lambda)$ correspond to the surface reflection and the coating/core interface reflection of the sample, respectively. Using Eqs. (2)-(4), Eq. (1) can be rewritten as $I(\lambda, t) = I_0(\lambda)S_r^2 + I_0(\lambda)(S_{s0}(\lambda)^2 + S_{s1}(\lambda)^2)$ $+2I_{0}(\lambda)S_{r}S_{s0}(\lambda)\cos\left[\frac{2\pi\Delta l(t)}{\lambda}\right]$ $+2I_{0}(\lambda)S_{r}S_{s1}(\lambda)\cos\left[\frac{2\pi\Delta l(t)}{\lambda}+\frac{4\pi d}{\lambda}\right]$ $+2I_{0}(\lambda)S_{r}S_{s1}(\lambda)\cos\left[\frac{2\pi\Delta l(t)}{\lambda}+\frac{4\pi d}{\lambda}\right]$

(5)

where the intensity of the incident light is $I_0(\lambda) = \sqrt{\varepsilon_0/\mu_0} |E_i(\lambda)|^2$. The first two terms in this equation are the mean (DC) intensities returning from the reference and sample arms of the interferometer, respectively. The third and fourth terms in this equation, which depend on the optical path length difference $\Delta l(t)$, represent the amplitude of the interference fringes that carry information about the surface position and the inner structures of the sample, respectively. The last term, the auto-correlation term, in the equations represents the interference fringe between the surface and the interface of the sample. Note that for a vibrating sample the optical path length difference is no longer a constant. The Fast Fourier transform (FFT) of the measured spectral interferogram provides both the surface position (i.e., $\Delta l(t)$) and the depth profile of the sample (i.e., $I_s(\lambda, t) \rightarrow I_s(z, t)$, where z is the depth direction).

3. Results and discussion

 $+2I_0(\lambda)S_{s0}S_{s1}(\lambda)\cos\left(\frac{4\pi d}{\lambda}\right)$

3.1. Characterization of inner structures of a static sample by OCVT

The inset of Fig. 1 shows a typical spectral interferogram measured for a static sample. The measured spectrum has a centre wavelength of $\lambda_0 = 700 \text{ nm}$ and a full width at halfmaximum (FWHM) of $\Delta\lambda$ =236 nm. Interference fringes are visible across the whole spectral range 400-1000 nm. The OCT axial resolution is calculated to be 0.9 µm in air, using the expression $(2\ln 2)/\pi \lambda_0^2/\Delta \lambda$ [18]. Fig. 2 shows the corresponding OCT-FFT waveform (FFT amplitude of the measured spectral interferogram). The main peak at 0 µm corresponds to the sample surface and the second peak at 38 µm corresponds to the polymer/plastic interface of the sample. The physical thickness of the layer d_2 is determined to be 25 µm, assuming that the refractive index n of the layer is 1.5. Generally, refractive index is



Fig. 2. The snapshots of OCT-FFT waveform of a micron-vibrating sample measured at the time of 140 ms (curve A), 156 ms (curve B) and 190 ms (curve C). The dashed double-arrowhead indicates the optical thickness of the polymer thin film (\sim 38 µm in air). The OCT-FFT waveform of the same sample at static is shown as the top curve. For clarity, all OCT-FFT waveforms are offset vertically.

defined as n = v/c, where c and v are the velocity of light in air and in medium, respectively; the physical thickness of the layer d_2 can be calculated as $d_2 = d_1/n$, where d_1 is the corresponding optical path length in air. Note that the axial resolution (defined as the FWHM of the main peak) achieved is 1 µm in air, one of the best ever reported. In addition, the second peak at 38 µm has a much smaller amplitude of 0.023, equivalent to about 1% change in the refractive index at the interface between the polymer coating and the plastic substrate. Therefore the OCVT developed provides a very efficient way for probing minor refractive index changes within a sample.

One distinct feature of our OCVT system is the combination of a broadband CCD-based spectrometer with a white light source [19], which has an extremely short coherence length. This configuration not only provides excellent axial resolution of 1 μ m in air (sun-micrometer in a sample), but also allows the whole spectral interferogram to be measured in a single shot (all frequency components were measured simultaneously by the linear sensor array of the spectrometer).

3.2. Characterization of a sample vibrating at a single-frequency by OCVT

This single-shot experiment scheme, together with the achieved sub-micrometer axial resolution, makes it possible to use the OCVT for quantitatively characterizing vibrating samples in real time. For this purpose, the same sample was mounted onto a loudspeaker whose vibration frequency and amplitude were controlled by a computer. Fig. 2 shows the snapshot of the OCT-FFT waveform measured at the time of 140, 156 and 190 ms. As expected, the position of the main peak of the OCT-FFT waveform changed with time, because the sample was vibrating along the axial direction. In addition, the extracted coating thickness of the sample remained constant at all three positions, suggesting that there is no measurable deformation of the sample used here.

Fig. 3(a) shows the 150 OCT-FFT waveforms of the vibrating sample recorded continuously over a period of 300 ms. The layer thickness can again be obtained from the peak position difference between the main and the small peaks. Furthermore, the peak position of the first main peak varies in a sinusoidal manner. The inset of Fig. 3 shows the plot of the peak position as a function of time, with Fig. 3 showing its corresponding FFT amplitude.



Fig. 3. (a) 3D map comprising 150 OCT-FFT waveforms of the vibrating sample recorded continuously in a period of 300 ms. The color scale corresponds to signal strength. The main peaks around $z=0 \ \mu m$ (*z* is depth direction) illustrate the surface position of a vibrating sample whilst the distance between the main and the small peak corresponds to layer thickness. For clarity, the signal above 25 $\ \mu m$ was enlarged by a factor 5. (b) The frequency distribution of the vibrating sample. The inset shows the plot of the peak position as a function of time.

The vibration frequency and the amplitude are subsequently retrieved to be 10 Hz and $8.1 \,\mu$ m, respectively.

The OCT-FFT waveform (that corresponds to the interference fringes) can be expressed as $I(z,t) = A(z,t) \exp(-i\varphi(z,t))$ [20]. In this paper, as demonstrated in Fig. 3, both the vibration amplitude and frequency of a vibrating sample are quantified by directly measuring the amplitude change A(z,t) between successive OCT scans. The surface displacement of a vibrating sample is obtained in real time by tracking the main peak position of the OCT-FFT waveform (Fig. 3). The vibration amplitude of the sample is then calculated as the max/min of the surface displacement (inset of Fig. 3(b)). Subsequently, by performing FFT on the temporal vibration signal, the vibration frequency can be quantified as well (Fig. 3(b)). Furthermore, the layer thickness can be obtained from the peak position difference between the main and the small peaks in OCT-FFT waveform of each OCT scan, as shown in Figs. 2 and 3. If there is no measurable deformation of the sample, as is the case in this study, the extracted layer thickness of the sample will remain constant for all the OCT scans. Therefore, the OCVT system developed here is a powerful tool for quantifying both the vibration characteristics and the inner structures of a sample simultaneously and in real time. We note that the phase change



Fig. 4. Comparison of the amplitude (a) and phase (b) 2D maps of a sample with a polymer film of 27 μm thickness (in air), recorded continuously in a period of 3000 ms. The sample is vibrating at a frequency of 1.5 Hz with an amplitude of 1.5 μm.

 $\Delta\phi(z,t)$ between successive OCT scan can also be used to characterize the inner structure of a sample, for example, to quantify tissue deformations [20,21]. As an example, Fig. 4(a) shows the 2D maps of another vibrating sample, which has a polymer film of 27 µm thickness (in air), recorded continuously in a period of 3000 ms. Here, the vibration amplitude and frequency were determined by analyzing the amplitude (A(z,t)) and the phase ($\Delta\phi(z,t)$) of the recorded waveform to be 1.5 µm and 1.5 Hz, respectively. This was done in a similar manner as aforementioned amplitude-change method: by firstly tracking the feature position of each OCT-FFT waveform, followed by performing Fourier transform of the resulting vibration curve. It can be seen from Fig. 4 that the resolutions of both the amplitude and phase maps are high and, therefore, they are both suitable for measurement of the low-frequency and ultra-fine-amplitude



Fig. 5. The measured surface position of a vibrating sample as a function of time (a), and its corresponding FFT amplitude (b). Vibration frequencies at 10, 70, 160 and 210 Hz were identified, which agree well with the frequencies of the applied excitation signal.

vibration. In addition, there is an oscillation feature between the surface and interface in the 2D phase map (Fig. 4(b)), whilst not shown on the 2D amplitude map. This indicates that the phase map is more sensitive to the minor inner-structures of a sample, albeit it is also more sensitive to measurement noise. Note that the straight lines at a depth of $5-10 \,\mu\text{m}$ correspond to the autocorrelation of the sample. Auto-correction artefact is due to the auto- and cross-correlated terms introduced by the reflections from various interfaces presented within the sample [22]. A phase shifting method has been used in the static OCT to eliminate the auto-correction artefact. In the vibration OCT reported here, the phase shifting method was not used as the auto-correlation is a time-independent "DC" term (refer to Eq. (5)), thus it would not affect the vibration measurement.

3.3. Characterization of a sample vibrating at multi-frequencies by OCVT

As a further demonstration of the OCVT capability, we drive the loudspeaker with a complex signal which has 4 frequency components (the combination of 10, 70, 160 and 210 Hz signals; the corresponding amplitude of the voltages added on the loudspeaker are 0.1, 0.07, 0.07 and 0.1 V, respectively). Again the spectral interferogram was recorded continuously for a period of 3000 ms and the extracted surface position was then plotted as a function of time in Fig. 5(a) (for clarity only the first 500 ms results are shown). It is evident from Fig.5(b) that all the vibration frequencies of the sample are successfully identified, demonstrating that the OCVT can be used for characterising sample vibrating at multiple frequencies.

In our current OCVT system, the minimum integration time of the spectrometer is limited to 1 ms, corresponding to 1000 measurements per second. This allows us to characterise vibrations with a frequency up to 250 Hz. This could be easily increased to a few KHz if the latest CCD-based spectrometer is employed. On the other hand, it has been shown that the surface quality of the finished products in high-precision machining is related not only to the amplitude but also to the frequency of the vibrations [1]. The frequencies, which affect the performance of most high-precision engineering, are from 0.5 to 70 Hz [1]. Therefore the proposed OCVT system is an ideal tool for in situ monitoring of these low-frequency micro-vibrations in high-precision manufacturing and measuring system [1,3]. The amplitude range of the microvibrations using the current vibration OCT system is about 0.1–80 μ m. The maximum measurable amplitude of the microvibrations is limited by the spectrometer resolution $\delta \lambda$ and is given by $z_{\text{max}} = \lambda_0^2 / 4 \delta \lambda$, where $\delta \lambda$ is the spectral resolution and λ_0 is the centre wavelength of the spectrum. For our current setup, $\lambda_0 = 700 \text{ nm}$ and $\delta \lambda = 1.5 \text{ nm}$, and this results in a maximum measurable amplitude of about 80 µm. A spectrometer with higher spectral resolution will improve this significantly. The minimum measurable amplitude of the micro-vibration. on the other hand, is ultimately limited by the accuracy of the resolved peak position of the OCT-FFT waveform. In our setup this is better than 0.1 um. although Liang et al. [21] reported an extremely high sensitivity at sub-nanometer level in studying tissue deformation. Spectraldomain OCT [18] was employed which is a noninvasive and crosssectional imaging technique and which permits, for example, micrometer-resolution three-dimensional images to be obtained from within the retina [17]. Previously it has also been used for detection and characterization of subsurface Hertzian cracks in ceramic materials [23] and for the in vivo thickness measurement of sweat film layer [24]. Liang et al. [21] used OCT technique to quantify the deformation of tissues that are subjected to slow dynamic compression (e.g. at about 0.1 Hz). The surface of the tissue was fixed. Our work is the first application of vibration OCT in quantifying both the surface displacement (amplitude and frequency) and the inner structures (layer thickness) of a sample vibrating at frequencies up to 250 Hz.

4. Conclusions

In summary, we have introduced a new technique for quantitatively characterizing the vibration and the inner structure of a sample simultaneously and in real time. The OCVT system developed can quantitatively characterise vibrations with a frequency up to 250 Hz, with an axial resolution of 1 μ m. The OCVT is non-contact and noninvasive in nature, thus is ideal for real time and in situ monitoring of vibration in high-precision manufacturing sector.

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